

**Notice of References Cited**

Application/Control No.

10/066,310

Applicant(s)/Patent Under  
Reexamination  
NEWBOLD ET AL.

Examiner

Chi Q Nguyen

Art Unit

3635

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,105,334	08-2000	Monson et al.	52/741.3
	B	US-6,514,054	02-2003	Liu, Ching-Wen	417/423.7
	C	US-6,272,794	08-2001	Rippel et al.	52/27
	D	US-5,758,959	06-1998	Sieczkowski, Philip	362/365
	E	US-6,263,619	07-2001	Gretz, Thomas J.	52/39
	F	US-6,533,559	03-2003	Hsieh, Hsin-Mao	417/423.5
	G	US-6,561,762	05-2003	Horng et al.	415/211.2
	H	US-6,309,190	10-2001	Chen, Chien-Jung	417/423.1
	I	US-4,219,307	08-1980	Bergdahl, Knut	415/220
	J	US-6,357,891	03-2002	Newbold et al.	362/147
	K	US-6,168,285	01-2001	Flohre, John Gerhard	362/96
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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